

Jordan Owens

Associate, New York



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Jordan Owens's practice focuses on intellectual property and technology-related litigation.

Ms. Owens attended Benjamin N. Cardozo School of Law as part of the Cardozo Scholars Program, where she graduated magna cum laude. During law school, Ms. Owens served as an Articles Editor of the Cardozo Law Review, a law journal dedicated to advancing empirical, interdisciplinary, and philosophical scholarship, as well as exploring cutting-edge national issues. She spent a summer in Washington, D.C. where she was part of the United States Patent and Trademark Office's Patent Experience Extern Program. She was named a 2018 David Berg Public Interest Fellow for her time at the USPTO. She was also an extern for a semester at Gottlieb, Rackman & Reisman, a New York based intellectual property law firm. She is the recipient of the faculty-selected Intellectual Property Award for outstanding performance in the field of Intellectual Property, and a member of the Order of the Coif.

Prior Experience:

- Summer Associate, Desmarais LLP, New York, New York 2019
- Extern, Gottlieb, Rackman & Reisman, P.C., New York, New York 2018
- Extern, United States Patent and Trademark Office, Alexandria, Virginia 2018

Other Distinctions

- Order of the Coif
- Benjamin N. Cardozo School of Law Intellectual Property Award
- Cardozo Law Review, Articles Editor
- 2018 David Berg Public Interest Fellow
- Cardozo Scholars Program Scholarship

EDUCATION

Benjamin N. Cardozo School of Law, J.D., 2020; *magna cum laude*; Cardozo Scholars Program Scholarship; Cardozo Law Review, Articles Editor

Northeastern University, Honors Program, B.S., Chemistry, Minor in Business Administration, 2017, *summa cum laude*; Dean's Scholarship; University Honors Program Distinction

ADMISSIONS

2021, New York